IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:			Docket No.:	6161.0025.C1
First Inve	ntor:	Woo-Young SO	Confirmation No.:	2192
Application	n No.:	10/801,146	Group Art Unit:	2112
Filed:		March 16, 2004	Examiner:	WHANG, Victoria P.
For: THII	N FILM	TRANSISTOR AND METHOD	OF MANUFACTUR	RING THE SAME
P.O. BOX	(1450	or Patents 22313-1450		
		CERTIFICATION	N STATEMENT	
Sir: Applic	ants ha	ave checked the appropriate box	es below.	
⊠1.	date o		irst Office Action or ing of a request for	n three months of the U.S. filing the merits OR before the mailing continued examination under 37
□ 2.	applic mater in the neces	ial. However, if an Office Action mail, the undersigned hereby at	d necessary to ens on the merits has i uthorizes the Comm s statement, includir	ure consideration of the submitted ssued and crosses this statement
□3.	filing o		of the first Office Ac	e than three months after the U.S. ction on the merits, but before the
	Stater foreig		nication from a forei e months prior to th	led in this Information Disclosure gn patent office in a counterpart e filing of this Information
	cited i to my in 37	n a communication from a foreig	gn patent office in a able inquiry, was kr e months prior to the	ormation Disclosure Statement was counterpart foreign application or, nown to any individual designated e filing of this Information
	□ c. <i>A</i> § 1.17		ount of \$ 180.00 in p	eayment of the fee under 37 C.F.R.

Woo-Young SO Application No. 10/801,146

□4 .	This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee. It is hereby requested that the Information Disclosure Statement be considered.
	a. I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(1).
	□ b. I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(2).
□ 5.	Relevance of the non-English language document(s) is discussed in the specification of the above-identified application.
(2) 6.	The document(s) was/were cited in a corresponding foreign application.
7 .	A concise explanation of the relevance of the non-English language document(s) appears below:
□ 8.	The Examiner's attention is directed to co-pending U.S. Patent Application No, filed, which is directed to related subject matter. The identification of this U.S. Patent Application is not to be construed as a waiver of secrecy as to that application now or upon issuance of the above-identified application as a patent. The Examiner is respectfully requested to consider the cited application and the art cited therein during examination.
<u> </u>	Copies of the documents were cited by or submitted to the Office in Application No, which is relied upon for an earlier filing date under 35 U.S.C. § 120. Thus, copies of these documents are not attached. 37 C.F.R. § 1.98(d).
	Respectfully Submitted,
	/hae-chan park/
	Hae-Chan Park Reg. No. 50,114

Date: January 11, 2007

CUSTOMER NO. 58027 HCP/WMH/kbs